Attorney Docket No: 0553-0394

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Shunpei YAMAZAKI et al.	)
Serial No.: 10/757,193	)
Filed: January 14, 2004	)
For: Method For Manufacturing Resist Pattern And Method For Manufacturing Semiconductor Device	)
Confirmation No.: 3577	)
Examiner: Brittany L. Raymond	)
Art Unit: 1756	)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

Applicants have the following response to the Office Action of December 7, 2006.

Please amendment the above-identified application as follows: